DATE: Tuesday, April 23, 2002

Set Name side by side	Query	Hit Count	Set Name result set	
DB=US	PT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR			
L17	sacrific\$4 with (solder adj mask)	7	L17	
DB=USPT; PLUR=YES; OP=OR				
L16	L15	3	L16	
L15	(solder with opening\$1 with BPSG)	3	L15	
L14	L3 and CMP	113	L14	
L13	(CMP with (contact or land\$3)) and solder	5	L13	
L12	4367119.pn.	1	L12	
DB=US	PT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR			
L11	solder with coat\$3 with tungsten	54	L11	
L10	solder with tungsten with (protrud\$3 or protrusion)	2	L10	
L9	L8 and (solder adj mask)	15	L9	
L8	(tungsten with solder) and (contact or bump)	405	L8	
L7	(tungsten with solder with mask\$3)	1	L7	
L6	(tungsten with plug with solder with mask\$3)	0	L6	
DB = US	PT; PLUR=YES; OP=OR			
L5	5550427.pn. and solder	0	L5	
L4	L3 and (solder with mask\$3)	201	L4	
L3	((438/597 438/612 438/613 438/614 438/615 438/616 438/617)!.CCLS.)	1311	L3	
DB=PGPB, $JPAB$, $EPAB$, $DWPI$, $TDBD$; $PLUR=YES$; $OP=OR$				
L2	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	23	L2	
DB=USPT; $PLUR=YES$; $OP=OR$				
L1	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	. 139	L1	

DATE: Tuesday, April 23, 2002

Set Name side by side	Query	Hit Count	Set Name result set	
DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR				
L18	(shape with bump with (aperture\$1 or opening\$1))	210	L18	
L17	sacrific\$4 with (solder adj mask)	7	L17	
DB=USPT; PLUR=YES; OP=OR				
L16	L15	3	L16	
L15	(solder with opening\$1 with BPSG)	3	L15	
L14	L3 and CMP	113	L14	
L13	(CMP with (contact or land\$3)) and solder	5	L13	
L12	4367119.pn.	1	L12	
DB = USPT, PGPB, JPAB, EPAB, DWPI, TDBD; PLUR = YES; OP = OR				
L11	solder with coat\$3 with tungsten	54	L11	
L10	solder with tungsten with (protrud\$3 or protrusion)	2	L10	
L9	L8 and (solder adj mask)	15	L9	
L8	(tungsten with solder) and (contact or bump)	405	L8	
L7	(tungsten with solder with mask\$3)	1	L7	
L6	(tungsten with plug with solder with mask\$3)	0	L6	
DB=USPT; PLUR=YES; OP=OR				
L5	5550427.pn. and solder	0	L5	
L4	L3 and (solder with mask\$3)	201	L4	
L3	$((438/597\ 438/612\ 438/613\ 438/614\ 438/615\ 438/616\ 438/617\)!.CCLS.\)$	1311	L3	
DB=PGPB, $JPAB$, $EPAB$, $DWPI$, $TDBD$; $PLUR=YES$; $OP=OR$				
L2	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	23	L2	
DB=USPT; $PLUR=YES$; $OP=OR$				
L1	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	139	L1	

DATE: Tuesday, April 23, 2002

Set Name side by side	Query	Hit Count		
side by side result set $DB = USPT, PGPB, JPAB, EPAB, DWPI, TDBD; PLUR = YES; OP = OR$				
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DB=USPT; PLUR=YES; OP=OR				
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L12	4367119.pn.	1	L12	
DB=US	PT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR			
L11	solder with coat\$3 with tungsten	54	L11	
L10	solder with tungsten with (protrud\$3 or protrusion)	. 2	L10	
L9	L8 and (solder adj mask)	15	L9	
L8	(tungsten with solder) and (contact or bump)	405	L8	
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L4	L3 and (solder with mask\$3)	201	L4	
L3	$((438/597\ 438/612\ 438/613\ 438/614\ 438/615\ 438/616\ 438/617\)!.CCLS.\)$	1311	L3	
DB=PGPB, $JPAB$, $EPAB$, $DWPI$, $TDBD$; $PLUR=YES$; $OP=OR$				
L2	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	23	L2	
DB=USPT; $PLUR=YES$; $OP=OR$				
L1	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	139	L1	

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DB=USPT; PLUR=YES; OP=OR			
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L1	semiconductor and (etch\$3 with oxide) and protrud\$3 and bump\$3	139	L1